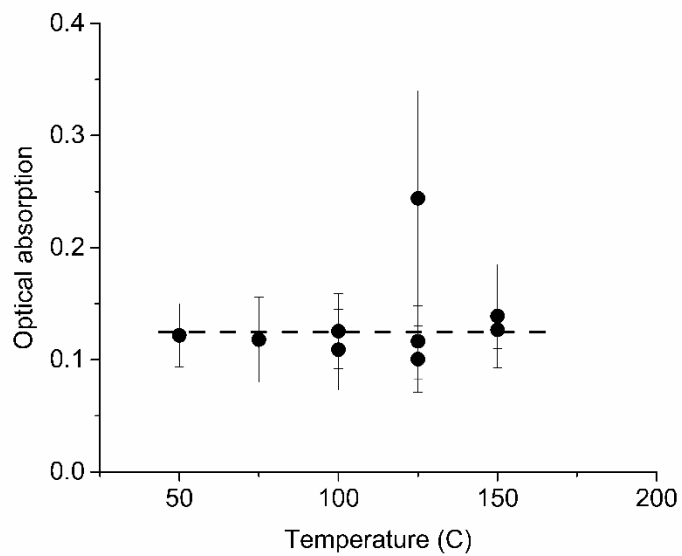


Nucleation as a function of purge pulse time, precursor pulse time = 2 s



Film thickness (using exciton absorption as a proxy) as a function of deposition temperature showing the existence of an ALD window.